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B / A

AMENDMENT UNDER 37 C.F.R. §1.312
EXPEDITED PROSECUTION - GROUP ART UNIT 2828

03500.013974

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TADAHIRO OHMI ET AL.) : Examiner: Davienne N. Monbleau
Application No.: 09/425,015) : Group Art Unit: 2828
Filed: October 25, 1999) :
For: GAS SUPPLY PATH)
STRUCTURE, GAS SUPPLY :
METHOD, LASER)
OSCILLATING :
APPARATUS, EXPOSURE)
APPARATUS, AND DEVICE :
PRODUCTION METHOD) May 19, 2004

Mail Stop: Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE

Sir:

a) Introductory Comments

This application having been allowed, kindly amend the subject application under 37 C.F.R. §1.312 as follows: